











FAZIA: Scientific case

Nuclear Equation Of State N/Z dependence $E(\rho,T, (N-Z)/A)$

SYMMETRY ENERGY versus

TEMPERATURE

T/T

_argest

fraament

- Nuclear Matter first Phase Transition ("Liquid-Gas")
- Nuclear level densities and Limiting temperature
- Symmetry Energy (density and temperature dependence)

LG

2 Model





NEED OF (A,Z) Identification



- B- RMF model

0.15

Effective field

BHF-Reid93 (continuous cl Self-consistent GF-Reid93 VMB-Argonne Av14

0.20

ρ (fm^{*3})

0.25

0.30











M. Preda.

Salmeron

Title: Dynamics & Thermodynamics of exotic nuclear s

Spokesperson(s) (max. 3 names, laboratory, e-mail - please und
one corresponding spokesperson):
F. Gulminelli (LPC-ENSICaen, Caen, France, e-mail: gub
G. Poggi (INFN & University, Florence, Italy, e-mail
G. Verde (INFN, Catania, Italy, e-mail: giuseppe
GANIL contact person
J. Frankland (GANIL, Caen, France)
Collaboration (names and labe
FRANCE: POLAND:
IPNO (Orsay): E. Bonnet, B. Borderie, E. Galichet, N. J. Kozik, Z. Sosin, A. Wieloch GANIL (Caen): A. Chbibi, J. Frankland, J. Moisart, J. Kozik, Z. Sosin, A. Wieloch Katowice (Silesian University): A. Grzeszczyk, S. Kowalski, W. Zinner
LPC-ENSICaen (Caen): S. Barlini, R. Bouge Lehaut, Warsaw (Warsaw University): A. Kordyasz, E. Piasecki
O. Lopez, B. Tamain, E. Vient ROMANIA:
<i>INDLA:</i> «
Baneriee.
ITALY: It aemanas require a new aetector system, FAZIA,
Bologna (Marini G
Catania (
Catania (I
Pirenze (II Olmi G Paso and S Piantelli A Stefanini
LNL (INFN): Nature ausero, M. Degerlier, F. Gramegna, V. Kravchuk
Napoli (INFN & University): M. La Commara, A. Ordine, E. Rosato, G.Spadaccini, M. 72 persons – 19 institutions – 8 countries
vignante

FAZIA LOI SPES

SPES-2015 FAZIA config. 1180 detectors Beam current: 132Sn 3.3*10⁷ pps ticalio target thickness: 0.5 mg/cm2 Reaction Xsection 3.2 barn; DIC Xsection 2 DIC total rate: 330 Hz 2-body channel: MC estimated eff. for QP & M>= Request: 10⁷ dissisipative e e most central impact parameters (b/b_{ar}<0.5) Rate for wanted evep' about 4.6days (this gives 35 mill ed elastic-Sn on the 3deg forward Telescope, 91¹ .ce) ne split of the QP) 3-body 10r (FF1& FF2 & M>=1 LCP): 10% MC es' assumed to be 20% of DIC 3b .ne previous 10⁷ binary events Re 3-body events 7Hz --> 2.7 million 3body events in 4.6days Rate

A and Z Identification

HEAVY-IONS COLLISIONS→IDENTIFY THE REACTION PRODUCTS

Energy is measured Z identification A identification (for low Z) For particles stopped in the first DE no identification



Energy loss = f(A,Z)

Energy is measured Velocity is measured A identification For particles stopped in the first DE no Z identification



A and Z Identification

HEAVY-IONS COLLISIONS→IDENTIFY THE REACTION PRODUCTS

1) RANGE = f(A,Z)

2) Plasma erosion process = f(A,Z)



Self field on (L.Bardelli, FAZIA)

USE THE ELECTRONIC SIGNAL FOR (A,Z) IDENTIFICATION: "Pulse Shape Discrimination"



FAZIA collaboration

An R&D project supported by Spiral2PP and LEA-colliga. It is aimed at designing a new-generation detector for charged particles, suited for Isospin Physics to be done *with n-poor and n-rich ions* at Radioactive Beam Facilities like Spiral2 and SPES (and EURISOL)

FAZIA Working Groups

- 1. Modeling current signals and Pulse Shape Analysis
- 2. Physics cases
- 3. Front End Electronics
- 4. Acquisition
- 5. Csl(Tl) crystals
- 6. Single Chip Telescope
- 7. Design, Detector, Integration and Calibration









- 1) Experiments with single silicon-detector (Tandem-Orsay, LISE-GANIL) Jan. 2006
- 2) Experiments with single silicon-detector & strip-detector (CIME/GANIL) & LNL (channeling & uniformity)

Jan. 2007

3) Prototypes (phase1)













RECIPE FOR HIGH QUALITY CHIPS

1 – DOPING UNIFORMITY

Ingot selection from the producer, controlled doping (at about ρ =3000 ohm.cm) and use of nTD technology for best uniformity (+/- 0.5 %)

2 – AVOID (as far as possible) CHANNELING

Ingot orientation and choice of the cut along special 'random' directions (7deg to <100>); slices of 300 and 500 microns



DOPING UNIFORMITY









FAZIA PhaseI-R&D

non-homogeneity in the electric field inside the detector (doping) may have a severe impact over the Pulse Shape Discrimination capabilities:





IMPROVEMENT IN DOPING UNIFORMITY

FAZIA data (INFN-Firenze)





CHANNELING

Energy loss in an crystal (aligned configuration):





"Channeled"

"Random"

......







IMPROVEMENT IN SIGNAL DISPERSION

FAZIA data (LNL)



RECIPE FOR HIGH QUALITY CHIPS

1-UNIFORMITE DU DOPAGE Ingot selection from the producer, control¹ <u>BEENAND</u> (at about ρ=3000 ohm.cm) and use of pTAS Bennology for best uniformity (+/- 0.5 %) 2-EVITER AU MIEUX LA CATHEREN Ingot orient of LOWING the cut along special 'random FOCLION (7deg to <100>); slices of 300 and 500

FAZIA PhaseI-R&D







FAZIA data (LNS)





FAZIA data (LNS)









isotopic identification up to Z~25 with ~5GeV full range

FAZIA PhaseI-R&D



FAZIA data (LNS)





FAZIA data (LNS)

FAZIA PhaseI-R&D



FAZIA PhaseI-R&D



FAZIA PhaseI-R&D





Pulse Shape of stopped particules is different: charge-carrier mobilities of electrons and holes, different plasma-erosion times



FAZIA data (LNS)



N.Le Neindre & R.Bougault (LPCCaen), FR-telescope LNS-July 2009

FAZIA PhaseI-R&D



FAZIA data (LNS)





FAZIA PhaseI-R&D



FAZIA data (LNL)



FAZIA PHASE2 "demonstrator & physics" :

• Built (2011-2013) a demonstrator of 192 telescopes Si/Si/CsI with "all" the finals (4π detector) electronics, mechanical solutions.

• With this demonstrator coupled to existing multi-detectors (INDRA, GARFIELD, CHIMERA,...), realize experiments (GANIL, SPIRAL2, LNL/SPES, LNS).

12 BLOCKS 48 MODULES 192 TELESCO) DPES Si/Si/Csl	
- Telescope Si(300μ) - charge 2 - charge - current Si(500μ) - charge - current CsI(phdiode)- charge	250 MeV f.s. 250 Ms/s 14 bit 4 GeV f.s 100 Ms/s 14 bit 250 Ms/s 14 bit 4 GeV f.s 100 Ms/s 14 bit 250 Ms/s 14 bit 4 GeV f.s 100 Ms/s 14 bit	













FAZIA@CHIMERA









FAZIA@GARFIELD

... and FUTURE:





(G.Casini et al. SPES-WS)

Spiral2

FAZIA Phase2 2011-2013

TECHNICAL CHOICE : Digitize as close as possible /preamplier

- Noise reduction
- Avoid signal distortion (PSA)
- Simplify signal transmission (high number of channels)

-	Telescope			
	Si(300µ)	- charge	250 MeV f.s.	. 250 Ms/s 14 bit
		- charge	4 GeV f.s	100 Ms/s 14 bit
		- current		250 Ms/s 14 bit
	Si(500µ)	- charge	4 GeV f.s	100 Ms/s 14 bit
		- current		250 Ms/s 14 bit
	CsI(phdiode	e)- charge	4 GeV f.s	100 Ms/s 14 bit

2 gains for the first Silicium detector



TECHNICAL CHOICE : Digitize as close as possible /preamplier



- 16 telescope "Block" structure
- 8 analog./dig. cards
- with mother board (communication, HV and "low bias")
- 1 optic fibber per "Block" (3Gbit/s)



PACI preamp. Charge & Current



(Card for 2 telescopes)

"Price to pay"

- 25 Watts per card
- Cooling system

(IPNOrsay, INFN Napoly)

(P.Edelbruck IPNOrsay)



TECHNICAL CHOICE : Digitize as close as possible /preamplier

Internal distribution of water (Cu 6mm)

Air test : Existence Of hot points (improve)

(INFN Napoly)

Kind til 10 berun 10. Saften fors Cheleford af Jugen Calific Statistics (af Jugen)				
	Electronic card temperature (top side)	50 °C	45_°C	
	Electronic card temperature (bottom side)	43 °C	4 0_ °C	
	Al shelf temperature	35 °C	3 2 ℃	
restance in a second se	Cu plate temperature	34 °C	28-°C	
22,9	TESTS under vaccuum			
47,7 •	Outgoing water temperature	25 °C	20 , 1 °C	
58,8+	Incoming water temperature	20 °C	17,5 °C	
	Cooling water flow	0,5 l/m	1 l/m	







Single Chip Telescope: no photodiode

Separation algorithm using ∆E and T_{rise}

FAZIA data (LNS) Analysis: Firenze



LNS (November 2009): "Radiation damage and PSA"

- A 300µm detector was placed at very forward angles
 - Mono-energetic (elastically scattered) Xe ions of 35 MeV/n are either implanted or punching-through, depending of absorbers, in narrow zones of the <u>same</u> Silicon detector
 - The detector was periodically irradiated and tested, in terms of energy and risetime resolution, by moving it far from the high flux region. Only elastically scattered Xe ions are measured (worst case)

20 mm

Si

• A total fluence of 1.2x10⁹ ions/cm² has been experienced by the detector



Standard irradiation zone: 2.5x10⁶/cm² implanted Xe ions (as for a real, safe experiment)

Punch-through zone: 6x10⁸/cm² punching-through Xe ions



Keeping the field constant by changing the biais Voltage

Standard irradiation zone: 2.5x10⁶/cm² implanted Xe ions (as for a real, safe experiment)

20 mr

20 mm

Keeping the field constant by changing the biais Voltage

Heavy damage zone: 6x10⁸/cm² implanted Xe ions

LNS (November 2009): Radiation damage and PSA

- The average effect of the increased reverse current (associated to local damage) can be fully recovered by simply keeping the field constant
- No significant effect is expected for the electronic noise (below 100 keV)
- Local damage is mainly associated to mono-energetic implanted ions (a narrow trapping layer is created at a depth="ion range"):
 - 2x10⁷ (Xe-like) ions per detector (4cm²) is the estimated limit for full Fazia performance for the energy and PSA of the same considered ions
 - minor degradation is observed in zones where ions have punched-through and fluences about 10² times higher can be sustained

$\frac{\text{NUCLEAR EQUATION OF STATE}}{E(\rho, (N-Z)/A,T)}$

Fragment production at 5.5 A.MeV

LIQUID PHASE

Isospin physics case from SPIRAL2/SPES (liquid phase) to GANIL/LNS high energies

FAZIA Phase2 2011-2013

Phase2 = "répétition générale" for several 1000 of telescopes

FAZIA PhaseI-R&D

Beyond ∆E-E: Z and A Identification with Pulse Shape Doping uniformity: nTD-silicon detector

Regular Silicon: +/- 15% uniformity – "regular" nTD silicon: below +/- 5% FAZIA nTD silicon: +/- 0.5%

Beyond ∆E-E: Z and A Identification with Pulse Shape Doping uniformity: nTD-silicon detector

DIGITAL PULSE SHAPE on 500µm and 300µm Silicons with similar field and different doping non-uniformities: 300µm: ~ 4 GeV full scale 500µm: ~ 4 GeV full scale

+/- 5% is not enough PSId. needs +/- 0.5%

It is possible (work with manufacturer)

Beyond ∆E-E: Z and A Identification with Pulse Shape Doping uniformity: nTD-silicon detector

DIGITAL PULSE SHAPE on 500µm and 300µm Silicons with similar field and different doping non-uniformities: 300µm: ~ 4 GeV full scale 500µm: ~ 4 GeV full scale

needs +/- 0.5% It is possible (work with manufacturer)

^{AE} IONS IDENTIFIED WITH TWO DETECTORS: USUAL DE/E-plot

LNL-Experiment

LNL-Experiment